

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

JOZEF D. MITROS ET AL.

Serial No.. 10/020,034 (TI-32931)

Filed December 7, 2001

For: METHOD FOR FABRICATING LOW CHC DEGRADATION MOSFET TRANSISTORS

Art Unit 2823

**Examiner Long Pham** 

Customer No. 23494

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Sir:

## **AMENDMENT UNDER 37 C.F.R. 1.111**

In response to the Office action dated December 17, 2003, please amend the above identified application as follows: